

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L5	375	semiconductor and (defect adj density) and (remov\$3 adj substrate)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/15 13:23
L6	288	I5 and epitax\$5	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/15 13:23